

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

CHEN et al.

Atty. Ref.: 2476-36; Confirmation No. 2845

Appl. No. 10/730,382

TC/A.U. 1795

Filed: 9 December 2003

Examiner: Angebrannt Martin J.

For: REVERSIBLE PHOTOBLEACHABLE MATERIALS BASED ON NANO-SIZED  
SEMICONDUCTOR PARTICLES AND THEIR OPTICAL APPLICATIONS

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December 18, 2007

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**SUPPLEMENTAL AMENDMENT**  
**&**  
**APPLICANTS' INTERVIEW SUMMARY RECORD**

Supplemental to applicants' 11/12/07 Amendment, please further amend the  
above-identified patent application as follows: